



Docket No.: 65781-012

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Yoshihiko NEMOTO, et al.	:	Confirmation Number: 3854
Serial No.: 10/603,982	:	Group Art Unit: 2812
	:	Allowed: December 11, 2003
Filed: June 26, 2003	:	Examiner: Gurley

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE WITH  
RECESSES USING ANODIC OXIDE (As Amended)

**LETTER SUBMITTING FORMAL DRAWINGS**

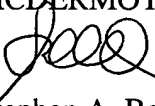
Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability dated December 11, 2003, submitted  
herewith are two (2) sheets of Formal Drawings in connection with the above referenced  
application.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

  
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